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CONFIRMATION NO. 8533

SERIAL NUMBER 10/529,742	FILING OR 371(c) DATE 01/06/2006 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. 268844US2PCT
APPLICANTS Hiroshi Shiho, Tokyo, JAPAN; Yukio Hosaka, Tokyo, JAPAN; Kuo Hasegawa, Tokyo, JAPAN; Nobuo Kawahashi, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/05963 04/23/2004				
** FOREIGN APPLICATIONS *****				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 17
				INDEPENDENT CLAIMS 3
ADDRESS 22850				
TITLE Polishing pad for semiconductor wafer and laminated body for polishing of semiconductor wafer equipped with the same as well as method for polishing of semiconductor wafer				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	